## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Heng Liu

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Title:

Chemical Vapor Deposition Reactor

JUN 2 8 2005

**Application No.:** 

10/621,049

Filing Date:

July 15, 2003

Examiner:

Ram N. Kackar

Group Art Unit:

1763

Docket No.:

M-15626 US

Confirmation No.:

8846

Irvine, California June 28, 2005

## Via Facsimile to (703) 872-9306

Mail Stop AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## PETITION FOR EXTENSION OF TIME

Dear Sir:

Applicants respectfully petition for a three-month extension of time within which to respond to the Office Action mailed December 29, 2004, such extension allowing Applicants until June 29, 2005 to respond.

Please charge the amount of \$510.00 (for a small entity) as set forth in the accompanying Transmittal Letter.

Certification of Facsimile Transmission

I hereby certify that this paper is being facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below.

Monique M. Butler

10621049

June 28, 2005

Date of Signature

Norman E. Carte Attorney for Applicant

Respectfully submitted,

Reg. No. 30,455

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